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2882

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/620,943 Confirmation No. 4054  
Applicant : Robert Keller  
Filed : 07/21/2000  
TC/A.U. : 2882  
Examiner : Kao, Chih Cheng G  
  
Docket No. : TI-30714  
Customer No. : 23494

**INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)**

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

  
William B. Kempler

1/5/04  
Date

Dear Sir:

In the matter of the above identified application, Applicants are submitting herewith copies of documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

In accordance with 37 CFR 1.97 (c), this Information Disclosure Statement is being submitted before the mailing date of a Final Action or a Notice of Allowance and is accompanied by the following certification specified in 37 CFR 1.97 (e).

On information and belief, I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

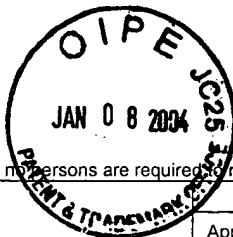
Pursuant to 37 CFR 1.97 (d), Applicants respectfully petition that this Information Disclosure Statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the Deposit Account No. 20-0668 of Texas Instruments Incorporated, and please credit any excess fees to such Deposit Account.  
**This form is submitted in triplicate.**

Respectfully submitted,  
Texas Instruments Incorporated

By   
William B. Kempler  
Senior Corporate Patent Counsel  
Reg. No. 28,228  
Tel.: (972) 917-5452

Please type a plus sign (+) inside this box ^  
0031



PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-

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<b>Substitute for Form 1449A/PTO</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				<b>Complete If Known</b>	
				Application Number	09/620,943
				Filing Date	07/21/2000
				First Named Inventor	Robert Keller
				Group Art Unit	2882
				Examiner Name	Kao, Chih cheng G
Sheet	1	of	1	Attorney Docket No.	TI-30714

U.S. PATENT DOCUMENTS						
Exam. Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
	AA	5,909,296		Tsacoyeanes	06/01/1999	
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					

FOREIGN PATENT DOCUMENTS								
Exam. Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)				
	BA	EP	0 962 796 A2		Congdon	12/08/1999		
	BB							
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Exam. Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	CA	Tuantranont A et al., "Smart Phase-Only Micromirror Array Fabricated by Standard CMOS Process", Proceedings of the IEEE 13 <sup>th</sup> Annual International Conference on Micro Electro Mechanical Systems, MEMS 2000. Miyazaki, Japan, Jan. 23-27, 2000, IEEE, U.S. 23 January 2000 (2000-01-23), pages 455-460, XP001045359 ISBN: 0-7803-5274-2.	
	CB		
	CC		
	CD		
	CE		
	CF		
	CG		
	CH		

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**US and Foreign Patent Documents:** <sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language Translation is attached.

**Other Prior Art/Non-Patent Literature Documents:** <sup>1</sup>Unique citation designation number. <sup>2</sup>Applicant is to place a check mark here if English Translation is attached.